



MICRO / MACRO SCRATCH TESTER

QSCRATCH 20 GO

The Qscratch 20 GO is a semi-automatic macro/micro scratch tester for standardized quality control of coatings and surfaces. It is designed for laboratories that require defined scratch tests, reliable operation, and traceable results – especially for single measurements with progressive or constant load.

The system combines a dynamically automated Z-axis, motorized Y-axis, electronic force control, and intuitive QpixControl2 software into a practical workflow for routine surface and coating testing. Scratch tests can be performed under controlled conditions, optically evaluated, and documented in structured test reports. The Qscratch 20 GO supports relevant standards including DIN EN ISO 20502, ASTM C1624, ISO 27307, and ASTM G171, making it a compact solution for production-oriented monitoring, routine testing, and reproducible scratch test results.



MICRO / MACRO SCRATCH TESTER QSCRATCH 20 GO

長所

- | Semi-automatic macro/micro scratch tester for defined quality check workflows
- | Compact solution for routine testing and production-oriented
- | Electronic force control with a test force range of 0.5–200 N
- | Constant and progressive load for standards compliant scratch testing
- | 8-position automatic tool changer for test modules and lenses
- | Dynamically automated Z-axis and motorized Y-axis
- | QpixControl2 software with guided scratch workflow
- | Structured evaluation and reporting for traceable results

MICRO / MACRO SCRATCH TESTER QSCRATCH 20 GO

3Dモデルを実世界で体験！



FEDAR

SHARE CHOOSE PRODUCT:

ARモデル - スマートフォンでページにアクセスするか、「部屋で見る」のQRコードをスキャンして、3Dモデルを現実の世界で体験してください！



Qscratch 20 GO



MICRO / MACRO SCRATCH TESTER QSCRATCH 20 GO

試験負荷の種類



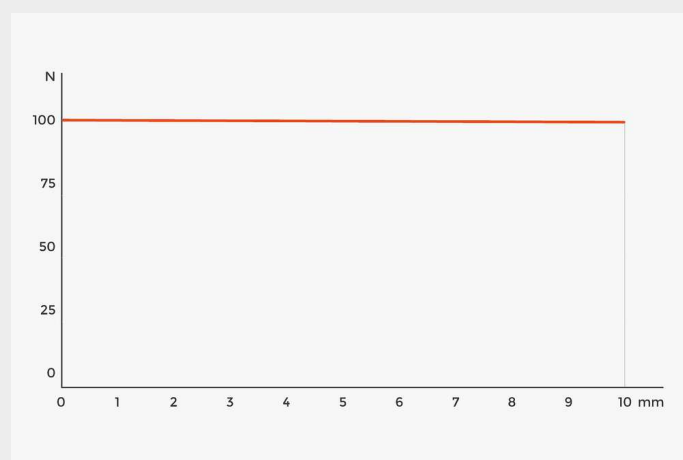
METHOD: PROGRESSIVE LOAD

The initial and final loads, as well as the load rate, are defined. The load increases along the scratch length; visible events can be assigned as Lc points at their respective positions.

ISO: PFST - progressive force scratch test

ASTM: PL - progressive load

Lc: Load critical



METHOD: CONSTANT LOAD

The normal force remains constant over the scratch length. This method is suitable for individual measurements, series comparisons, and recurring test conditions in a quality control setting.

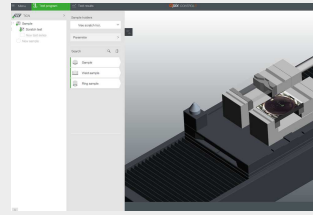
ISO: CFST - constant force scratch test

ASTM: CL - constant load

Lc: Load critical

TEST METHODS

PROGRESSIVE OR CONSTANT
LOAD -
TAILORED TO THE TEST
REQUIREMENTS



STANDARDS & PROCEDURES

DIN EN ISO 20502 / ASTM C1624 -

Determination of adhesion and mechanical failure modes of hard ceramic coatings using a scratch test.

ISO 27307 - Evaluation of the adhesion and cohesion of thermally sprayed ceramic layers on a cross-section using a transverse scratch test.

ASTM G171 -

Determination of the scratch hardness of material surfaces using a defined diamond stylus, a constant normal force, and evaluation of the remaining scratch width.

FOR LABORATORIES THAT MAKE CRITICAL DECISION EVERY DAY

Qscratch 20 is a automated macro/ micro scratch tester for coatings and functional surfaces. The system combines controlled force application, integrated optical evaluation, and guided software operation and a report generation. It was developed specifically for laboratories that make critical surface-related decisions on a daily basis.

PRACTICAL QUALITY ASSURANCE & INTEGRATED WORKFLOWS

Designed for quality assurance: The system combines standardized scratch tests with high repeatability, efficient documentation, and intuitive operation. QpixControl2, the integrated workflow, flexible export options, and optional inspection functions turn it into a powerful, all-in-one solution rather than a simple stand-alone tester.

LONG-TERM INVESTMENT SECURITY THROUGH QATM EXPERTISE

QATM brings many years of experience in hardness testing, metallography, and global service to its scratch testing portfolio, thereby safeguarding your investment in the long term.

TEST PRINCIPLE DIN EN ISO 20502 | ASTM C1624

A DEFINED SCRATCH. A CONTROLLED LOAD. A CLEAR

EVALUATION.

The principle

In the scratch test, a diamond stylus is moved across the coated surface under a defined normal force. Visible events such as cracking, spalling, or penetration of the coating are localized along the scratch mark and assigned to the corresponding critical load. Thus, the scratch mark not only indicates that a failure is occurring; it also shows where it is occurring—and makes the load at the critical point traceable.



DEFINING AND ASSIGNING FAILURE EVENTS

Lc1 - Initial cracking / plastic deformation

Lc2 - Spalling

Lc3 - Penetration of the coating down to the substrate

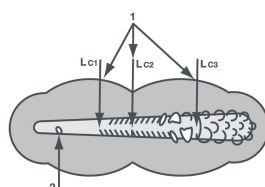


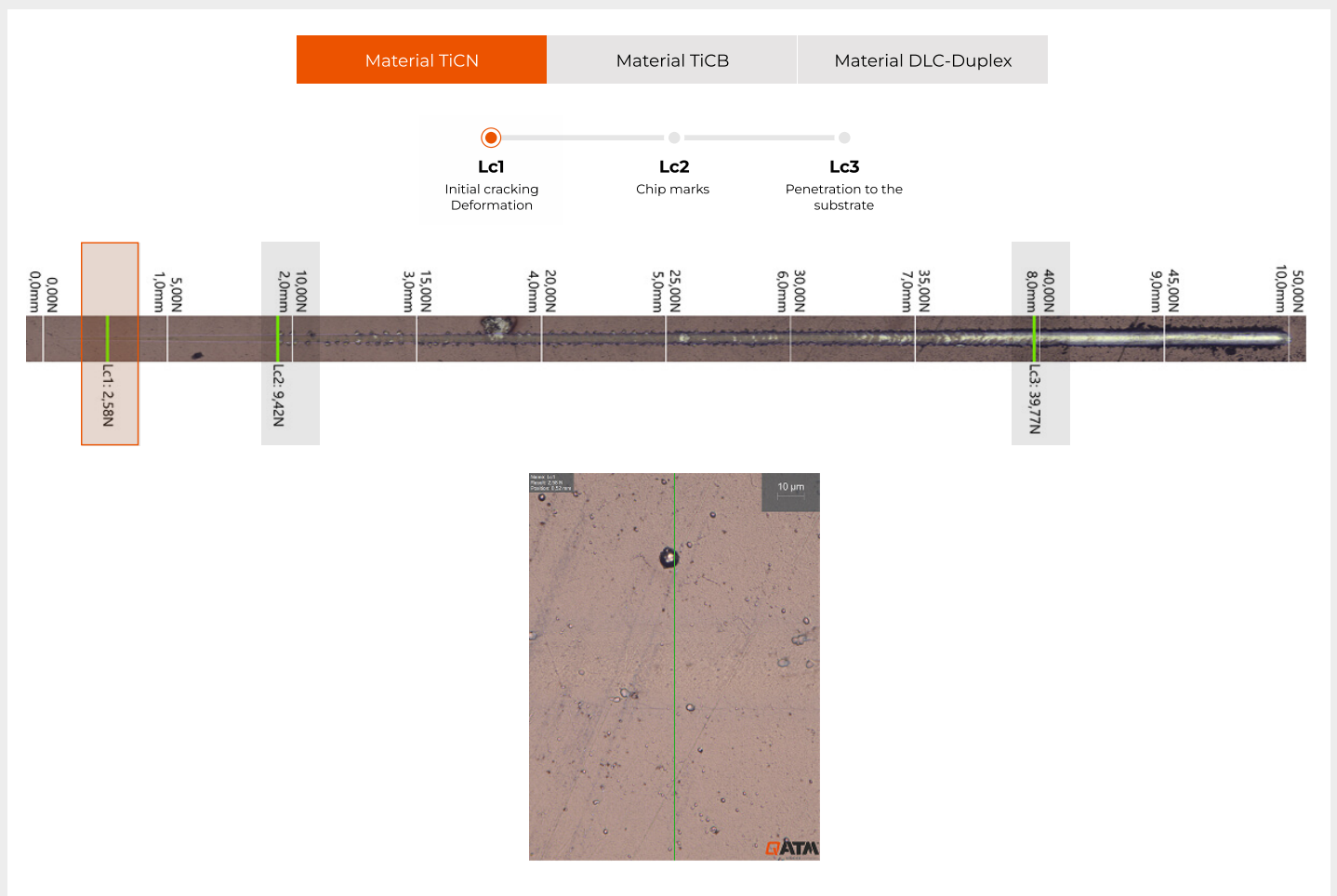
Figure: Failure Events

FROM SCRATCH TRACK TO TRACEABLE RESULT

CERAMIC COATINGS. EVALUATION OF ADHESION AND FAILURE MODES.

The following interactive section shows how typical failure events along the scratch track are analyzed. Click on the LC points to see how cracking, spalling, and coating penetration are associated with specific positions and loads.

SELECT A MATERIAL AND EXPLORE THE LC POINTS



**THIN, HARD CERAMIC
COATINGS (TYPICALLY 0.1 - 30
MM)**

- | Carbide, TiC, CrC
- | Nitride TiN, CrN, TiAlN
- | Oxide Al_2O_3
- | Diamond Diamond coating
- | Diamond-like carbon DLC

**THIN, HARD CERAMIC AND
TECHNICAL COATINGS
(TYPICALLY ≤ 20 MM)**

- | PVD TiN
- | PACVD DLC
- | Arc-discharge DLC
- | PVD/PACVD Cr-C
- | PVD Al_2O_3
- | Hard chrome

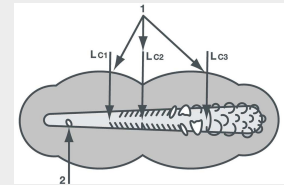


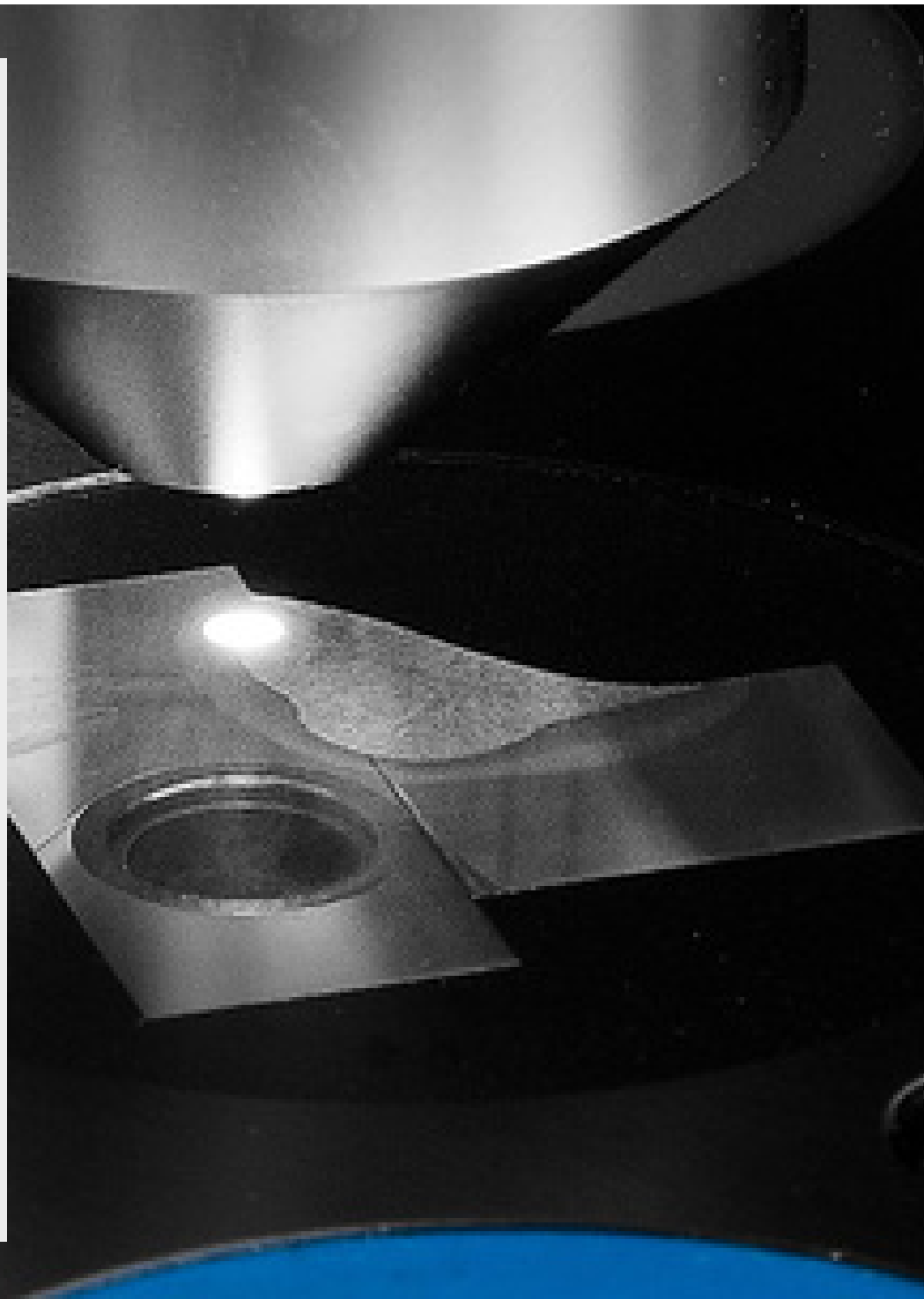
Figure: Failure
Events

MICRO / MACRO SCRATCH
TESTER QSCRATCH 20 GO

画期的な光学システム

The QATM-developed, in-house manufactured lens system sets new standards. As well as providing crystal clear image quality for hardness testing, Koehler illumination uses white LED light and motor-operated aperture shuttering to produce ideal contrast, even for high magnification images.

Experienced metallurgists agree the image quality provided by the Qscratch is comparable in all aspects with that of established sophisticated microscopes. The up-to-date concept and new lenses in the optic system enable the device to completely meet even the strictest physical 'test system definition' requirements in compliance with DIN EN ISO6507-1/2:2018.



MICRO / MACRO SCRATCH TESTER QSCRATCH 20 GO

革新的なオペレーション



テストスペースの照明

すべての機器に新開発のLED作業用照明を搭載。シングルピーステストのためのサンプルの位置決めが容易になりました。

点灯するステータス表示

暗闇に光をもたらす

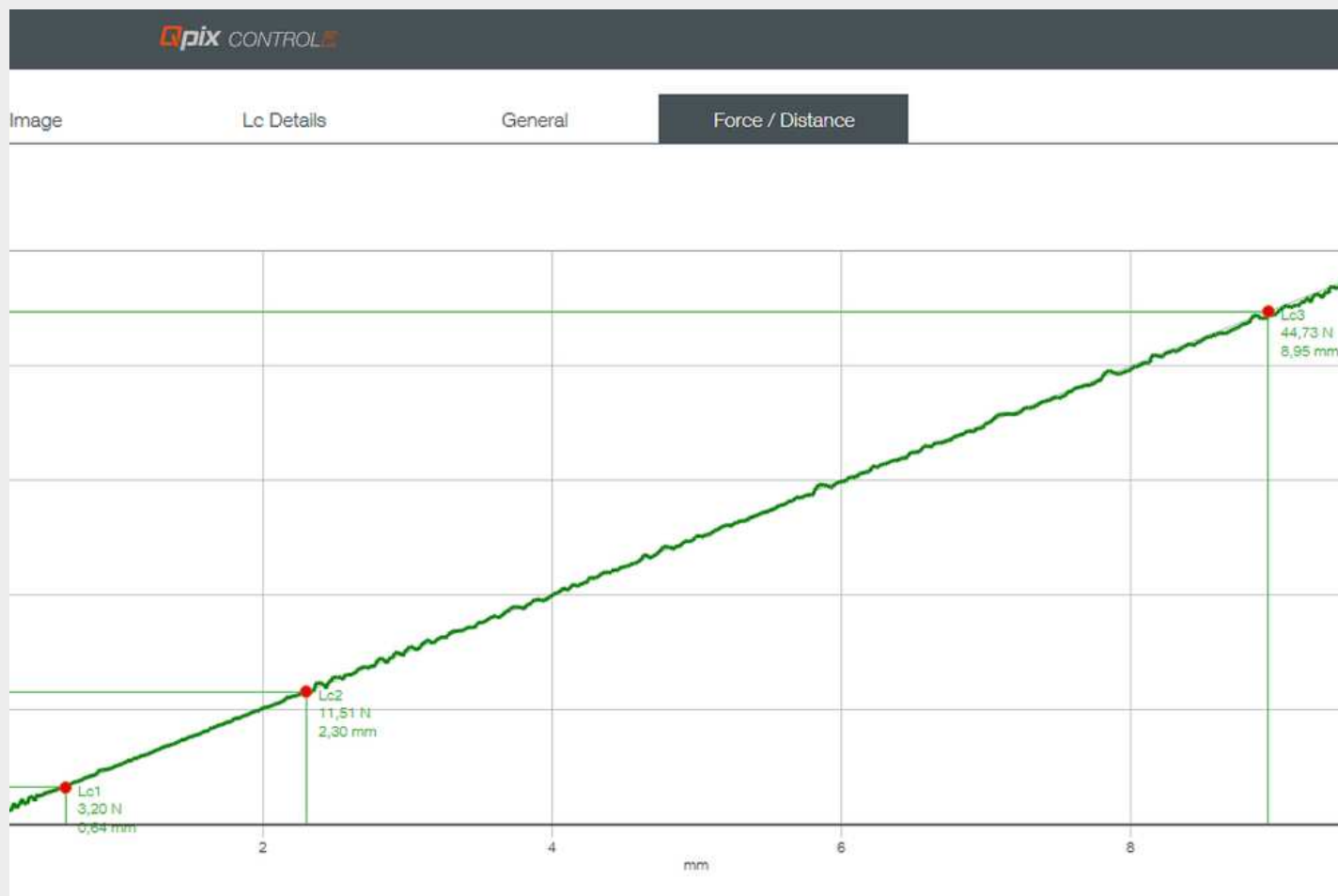
The illuminated QATM logo displays the current device status at a glance. The range of flash intervals indicates whether the device is operating automatically or is free to be used for new tasks for staff all around the lab. In addition, the LED test space lighting, installed as standard, ensures that samples and sample holders are positioned correctly.

On the Qscratch 20, it also ensures uniform light intensity for sample imaging.



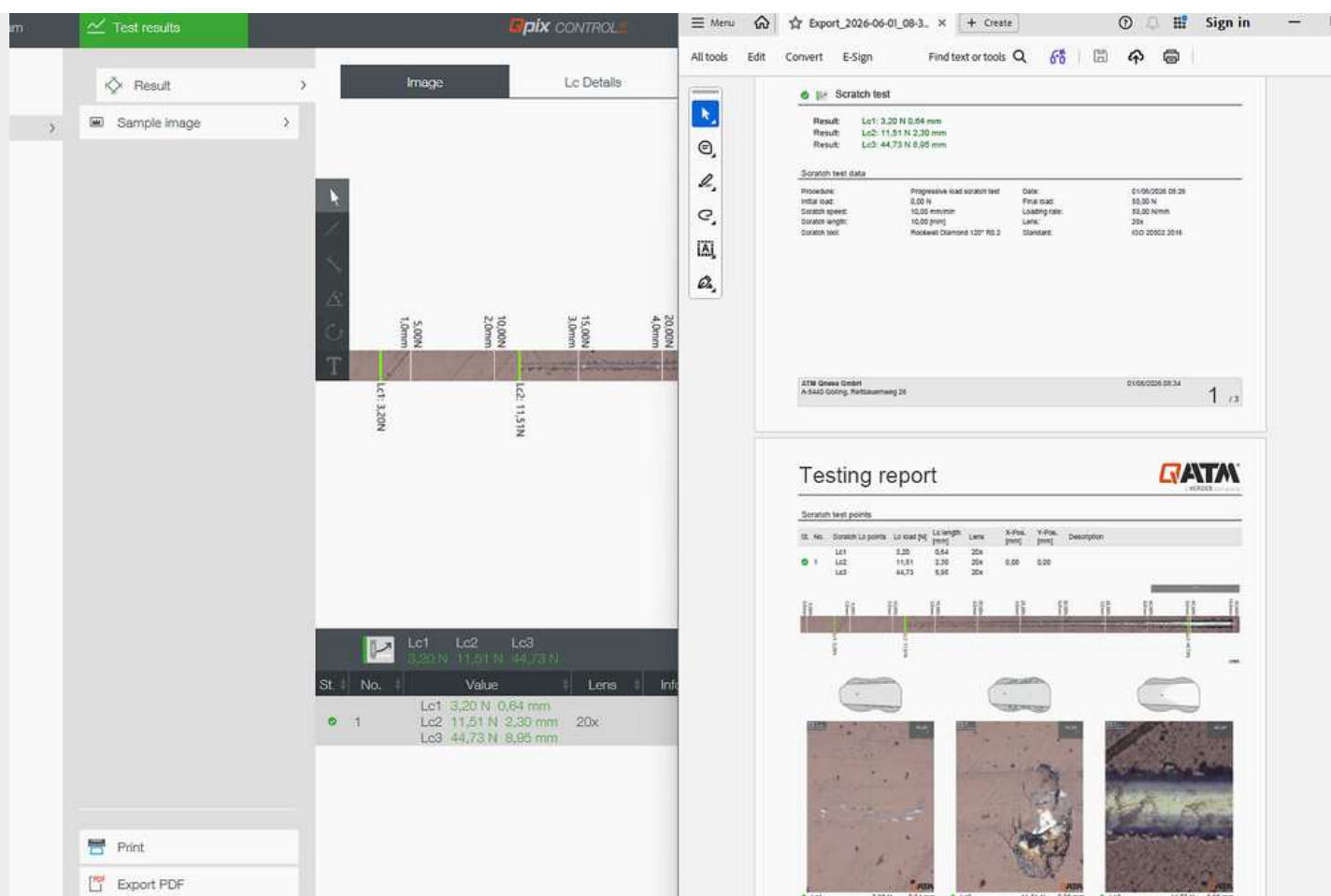
MICRO / MACRO SCRATCH TESTER QSCRATCH 20 GO

先駆的な技術 - ユニークな実装



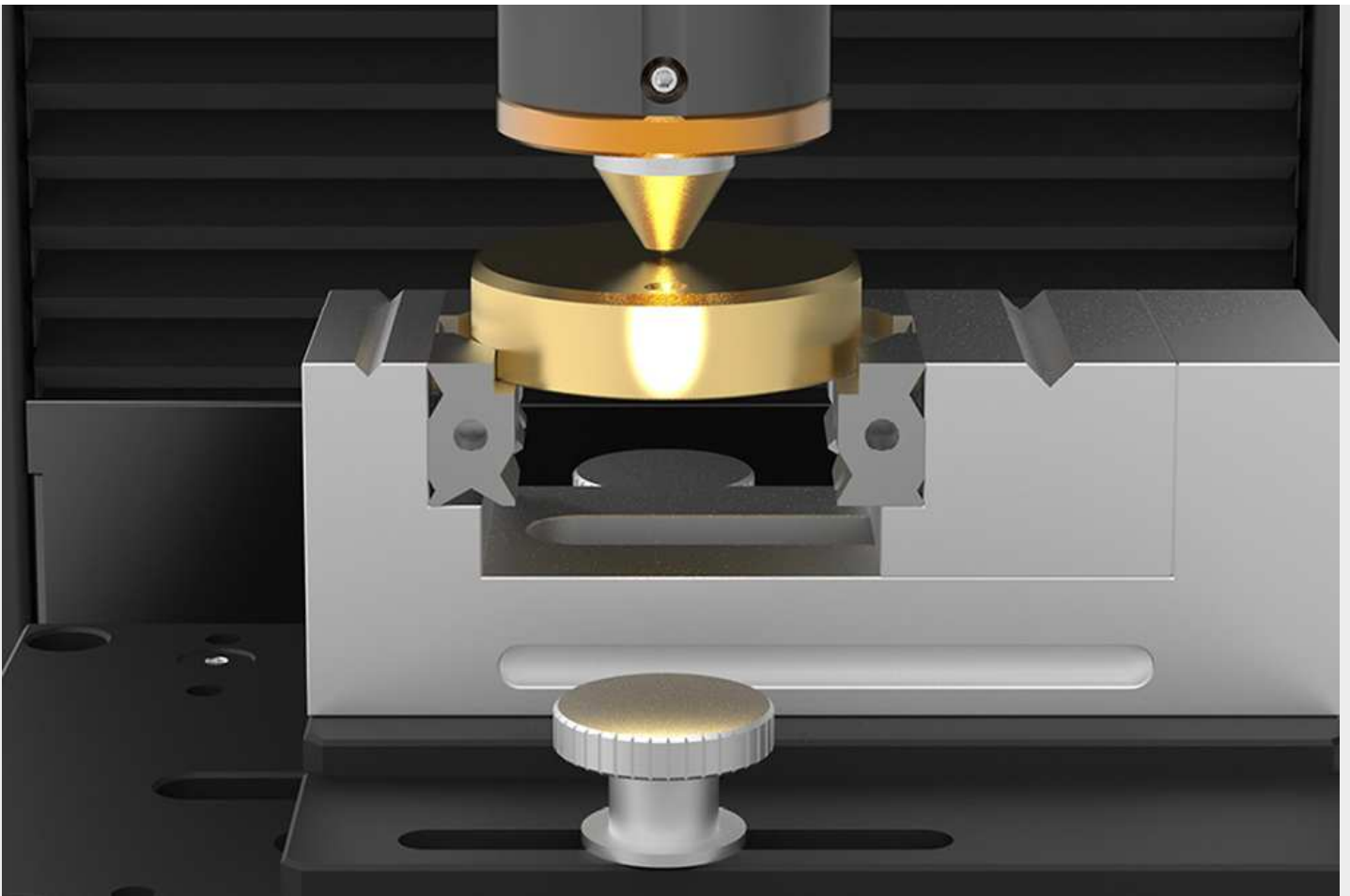
PRECISE DISTANCE / FORCE APPLICATION

Precise electronic load control ensures that the test load—as a critical test parameter—remains controlled, reproducible, and traceable at all times.



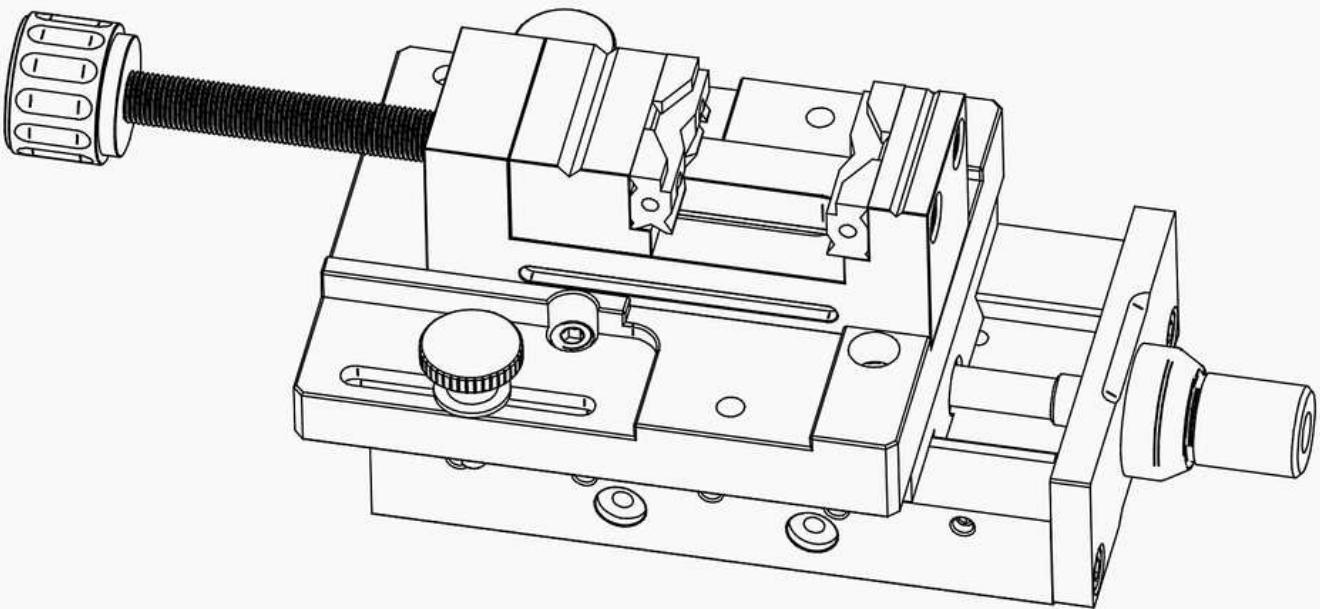
EVALUABLE AND COMPARABLE

The selected loading logic is linked to the scratch mark, position, and result. Methods can be applied to sample series, coating variants, and process comparisons.



UNIVERSAL SAMPLE HOLDER

Adjustable clamping jaws allow for the secure holding of various specimen geometries - from flat and angular test pieces to round or very small specimens.



OPTION

MULTI MEASUREMENT

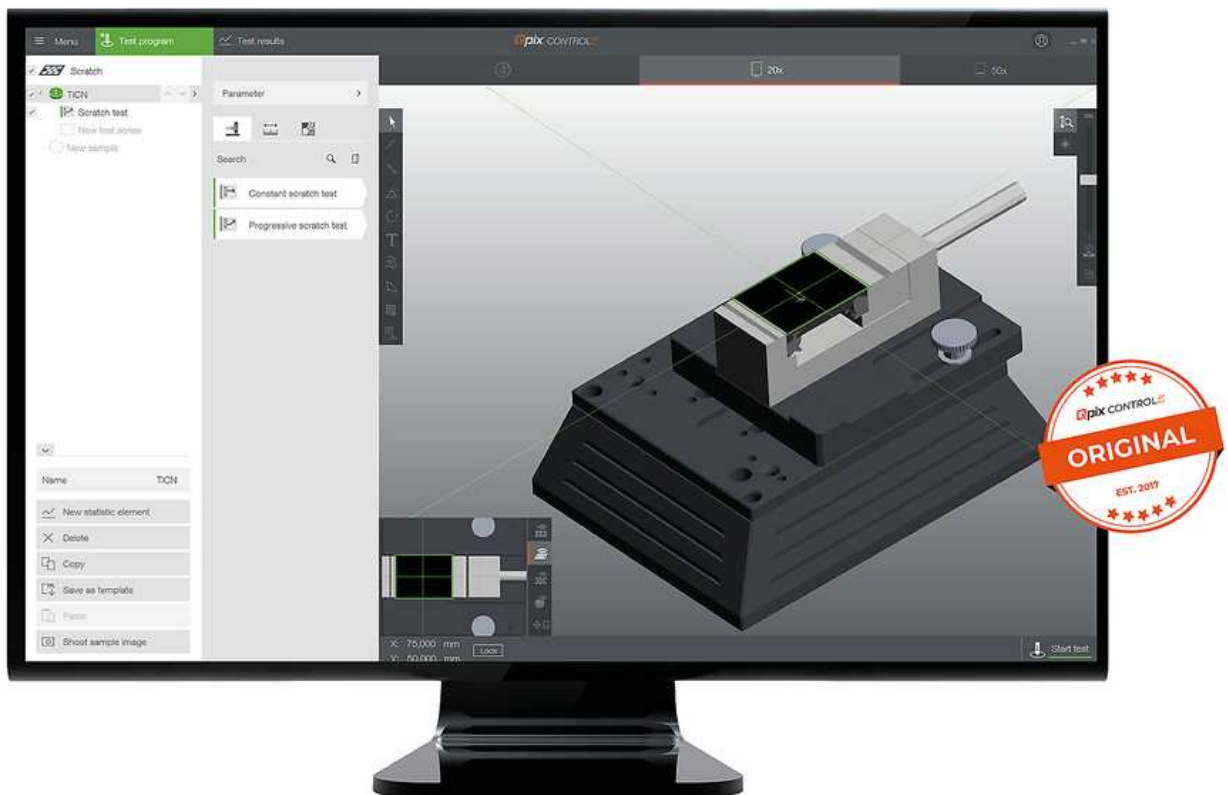
The optional manual X-axis slide shifts the sample laterally, enabling multiple scratch tracks on one specimen – ideal for comparisons and small test series.

Qpix CONTROL²

SCRATCH WORKFLOW

EASY TESTING, EFFICIENT ANALYSIS

QpixControl2 is more than just a user interface: The software combines a patented 3D user concept with a seamless scratch workflow. Tests can be easily created, scratch marks visually positioned, single measurements processed automatically, and relevant Lc events evaluated in a structured manner. From test definition through image capture and evaluation to data management, export, and standardized reporting, all steps remain integrated within an intuitive software environment. This reduces operational effort, supports reproducible processes, and enables the efficient use of scratch testing in production-oriented quality assurance.



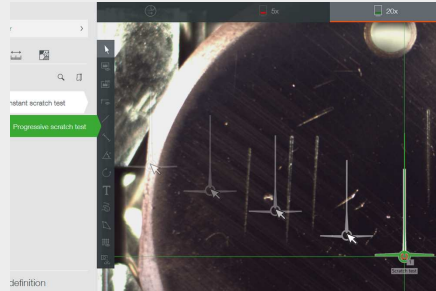
FROM SETUP TO REPORT

試料の装着, パターンの設定, 試験の開始



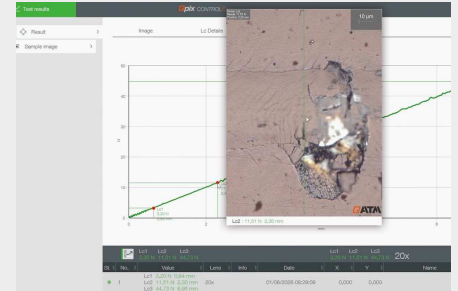
1. LOAD SAMPLE

The sample holder is automatically moved to the correct height, and the sample image is automatically captured.



2. POSITIONING

Drag and drop the starting point of the scratch test directly to the desired position.

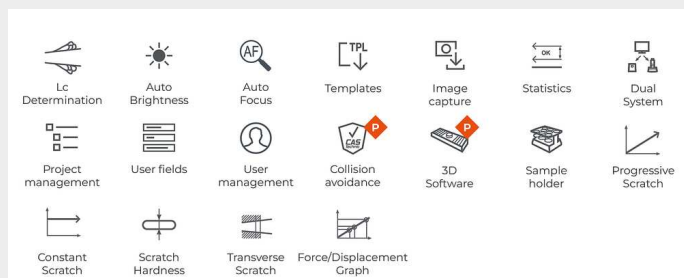


試験の開始

The test sequence is fully automatically and in accordance with the Scratch test standards. Subsequently, the failure events can be evaluated and assigned to the respective Lc points.

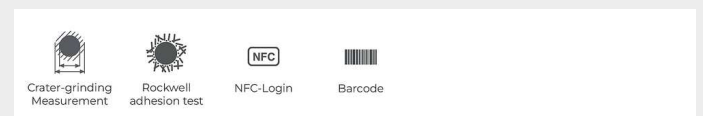
ソフトウェア

INCLUDED FEATURES

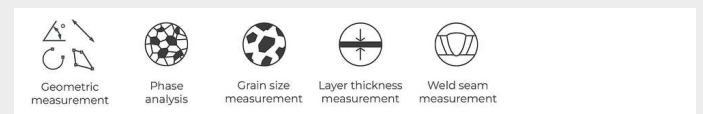


ソフトウェア

オプション

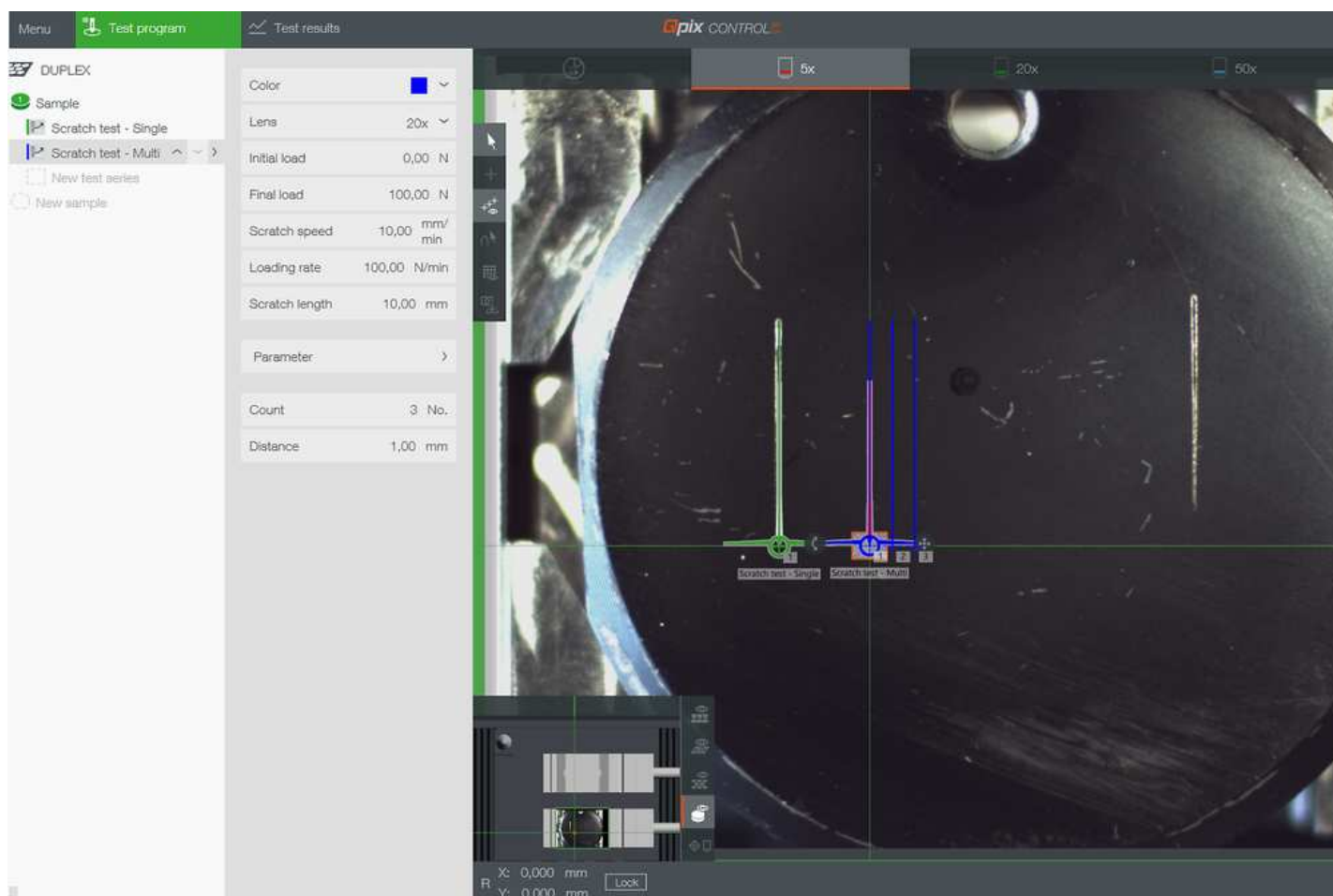


顕微鏡と分析



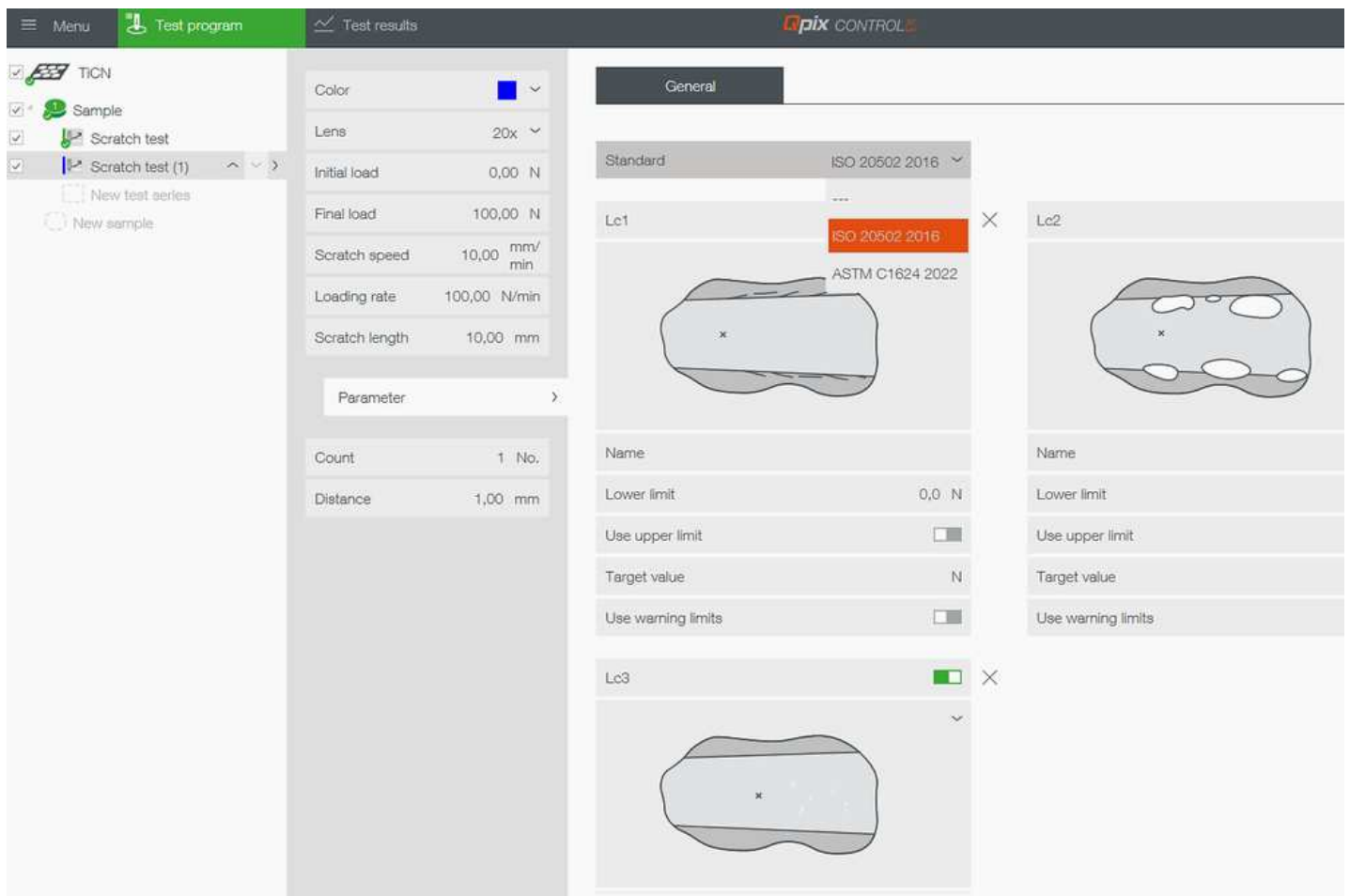
QPIX CONTROL2

革新的なソフトウェア機能



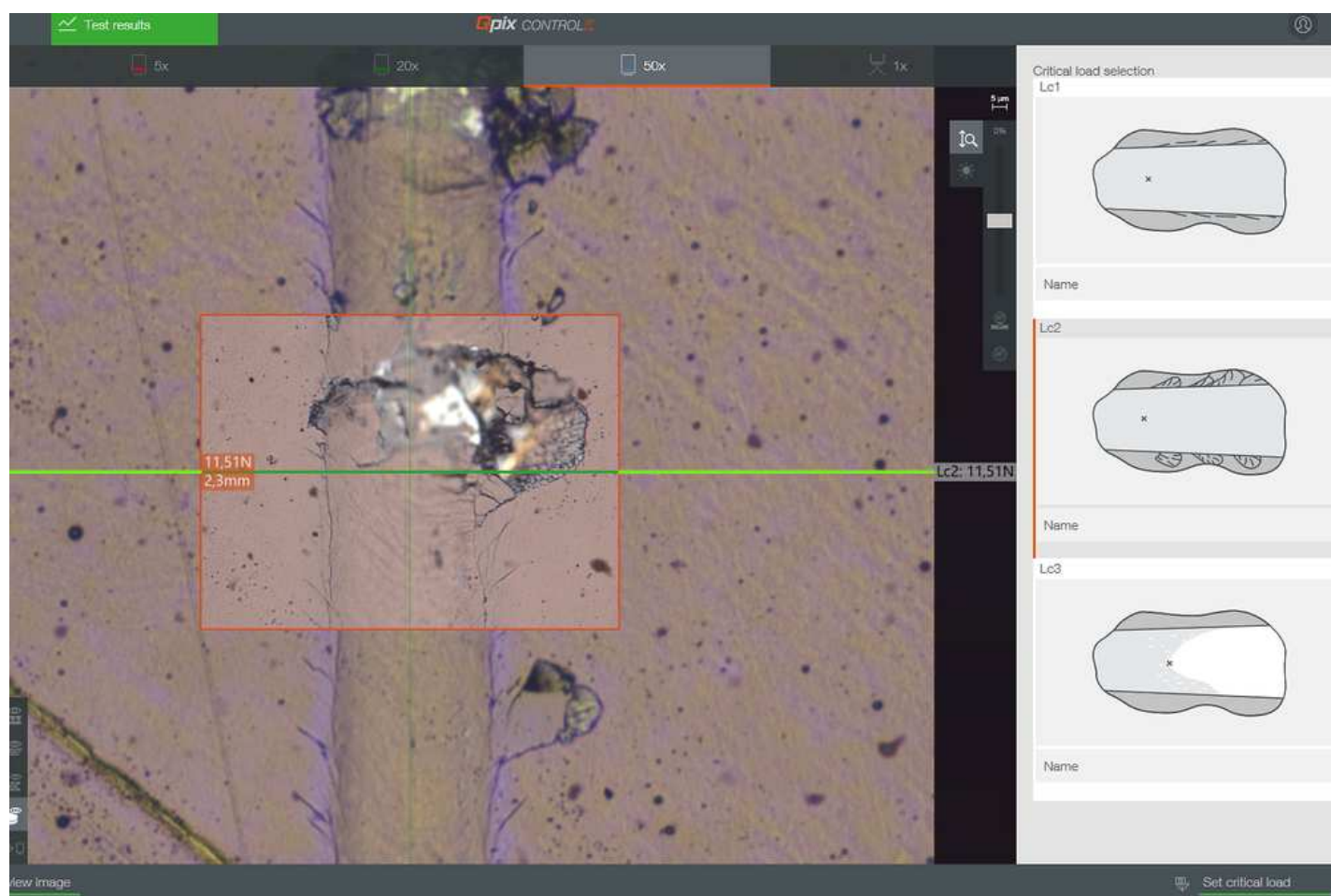
SINGLE AND MULTIPLE INSPECTIONS

Single or multiple measurements: Scratch marks can be positioned directly in the software, created with a defined offset, and processed automatically. The Lc results are evaluated for each test as well as as a series mean.



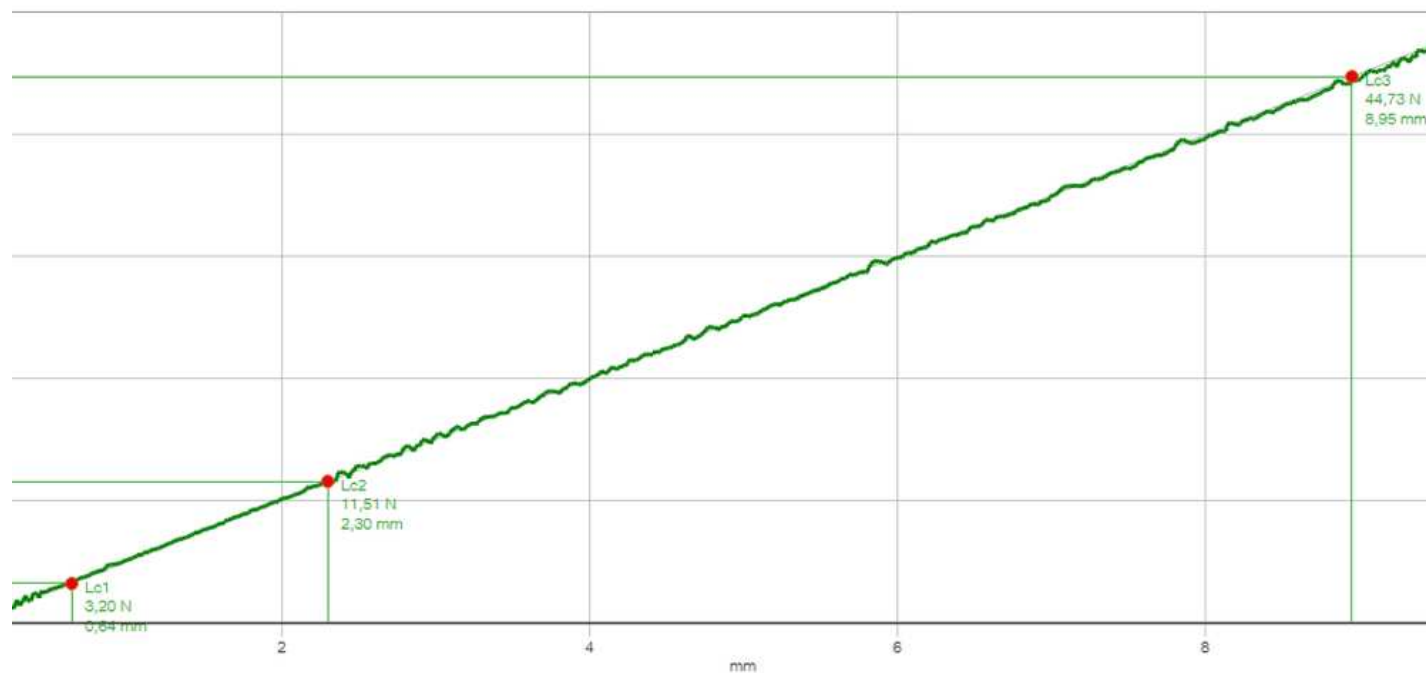
A WIDE RANGE OF SETTING OPTIONS

Load definition, crack length, load rate, speed, and lens selection are managed directly within the method. For evaluation, standardbased templates or custom templates can be used and supplemented with limit and target values.



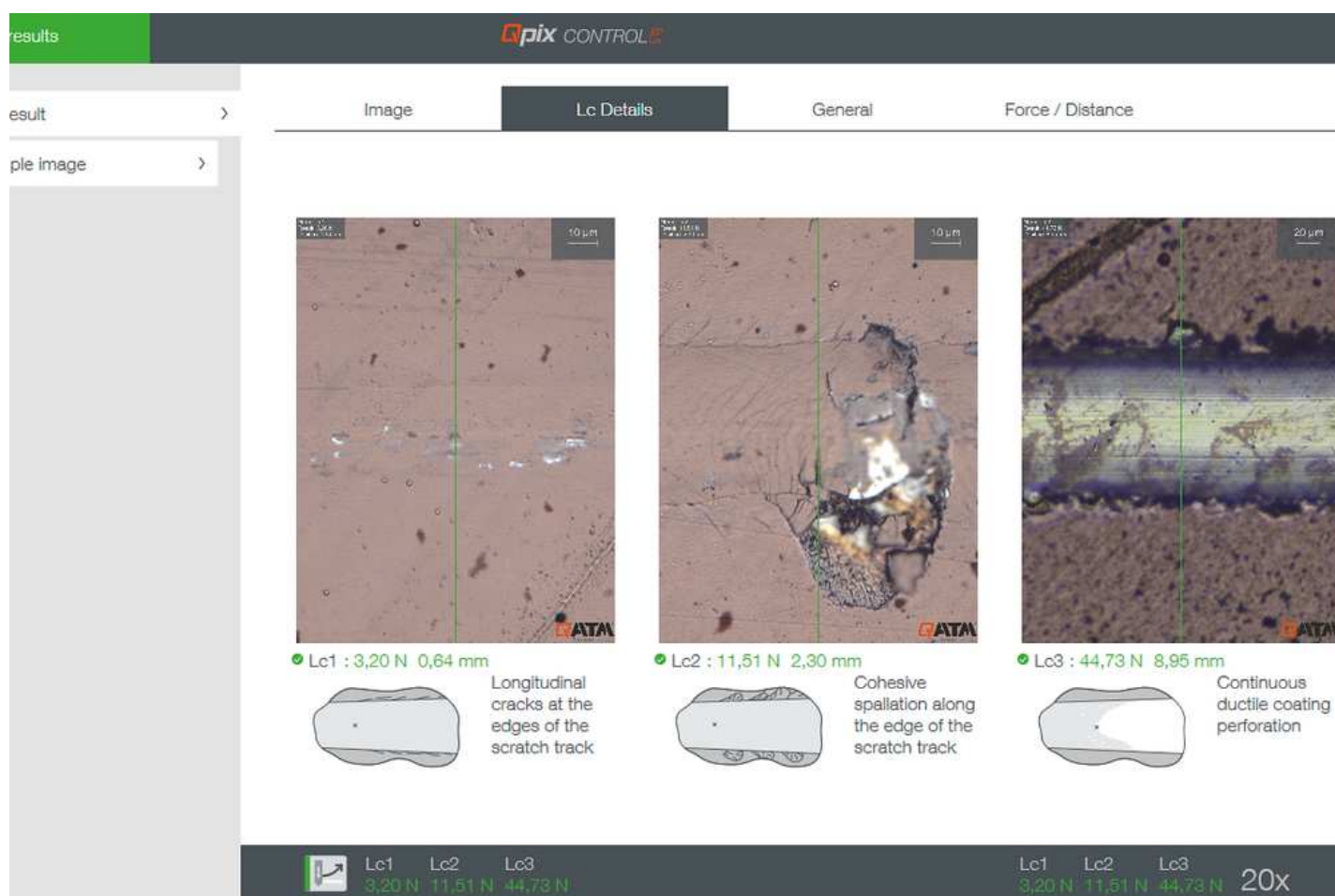
GUIDED LC DETERMINATION

Graphical templates support the consistent classification of typical failure events. This facilitates standard-based procedures and reduces room for interpretation.



FORCE/DISTANCE GRAPH

The force-distance curve documents the applied load along the scratch track. Anomalies in the curve can be compared with visible failure events and used for Lc evaluation



LC DETAILS

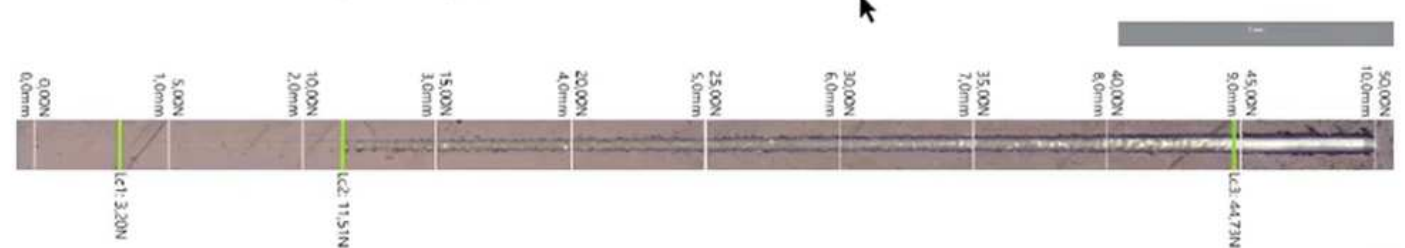
Relevant failure events along the scratch track can be viewed in detail in the image and assigned to the corresponding Lc details. This transforms the visual assessment into a verifiable test result

Scratch test data

Procedure:	Progressive load scratch test	Date:	01/06/2026 08:26
Initial load:	0,00 N	Final load:	50,00 N
Scratch speed:	10,00 mm/min	Loading rate:	50,00 N/min
Scratch length:	10,00 [mm]	Lens:	20x
Scratch tool:	Rockwell Diamond 120° R0.2	Standard:	ISO 20502 2016

Scratch test points

St.	No.	Scratch Lc points	Lc load [N]	Lc length [mm]	Lens	X-Pos. [mm]	Y-Pos. [mm]	Description
✓	1	Lc1	3,20	0,64	20x	0,00	0,00	
		Lc2	11,51	2,30	20x			
		Lc3	44,73	8,95	20x			



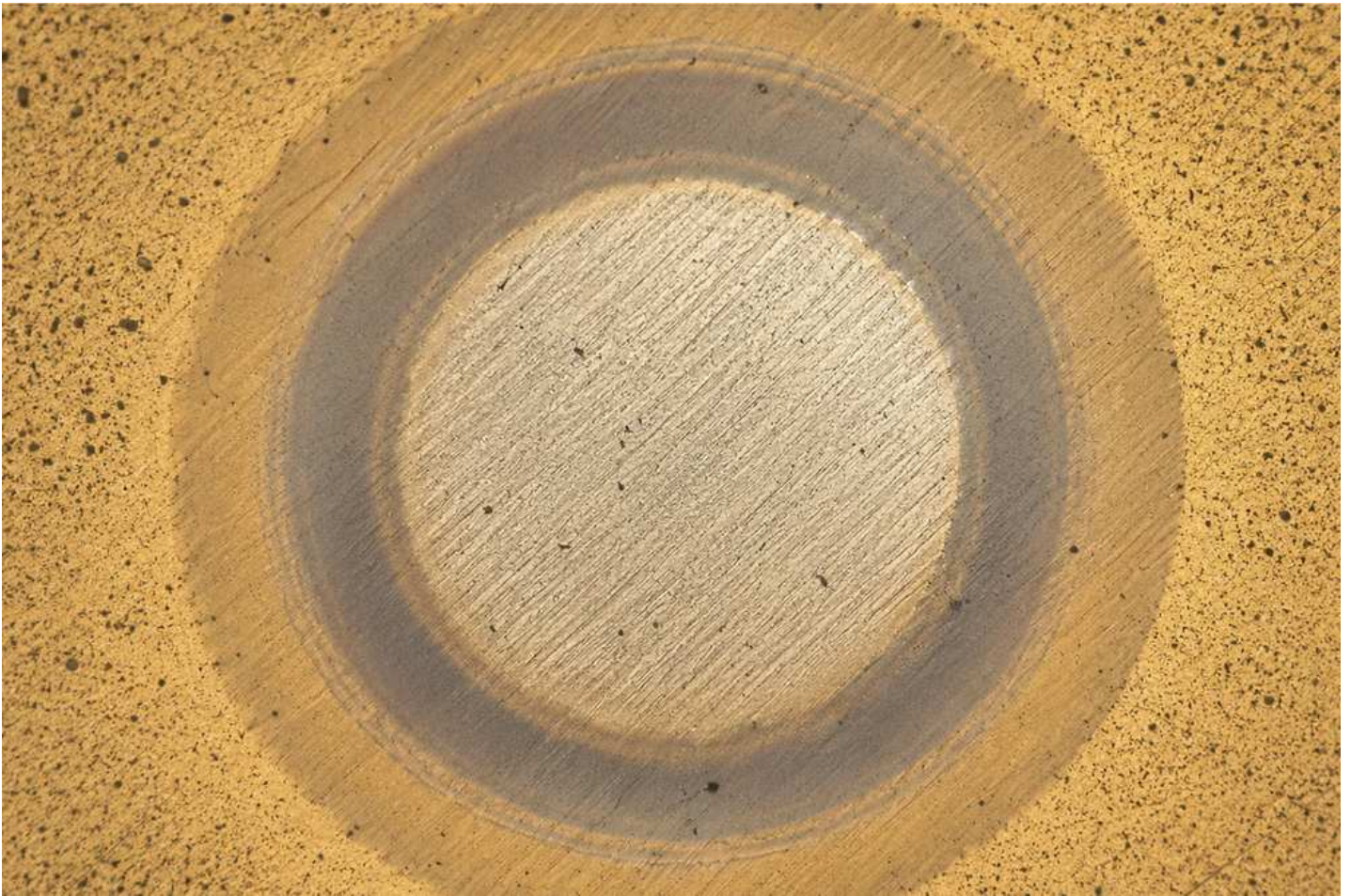
REPORT

Test parameters, scratch track, Lc values and evaluation results are compiled into a test report. This simplifies documentation, the comparison of test series, and the dissemination of results within the quality process.

COATING INSPECTION MADE EASY

QPIX INSPECT FOR CRATER-GRINDING AND ROCKWELL ADHESION TESTING

The optional Qpix Inspect modules expand the Qscratch 20 with practical functions for coating evaluation. Crater-grinding supports microscopic coating thickness measurement in accordance with DIN EN ISO 26423, while the Rockwell adhesion test enables qualitative adhesion evaluation of ceramic coatings in accordance with DIN EN ISO 26443. This allows additional information on coating quality to be captured, evaluated, and documented directly within the familiar QpixControl2 software environment.



CRATER-GRINDING COATING THICKNESS MEASUREMENT

Crater-grinding method for microscopic coating thickness determination as supplementary information for coating evaluation in accordance with DIN EN ISO 26423.



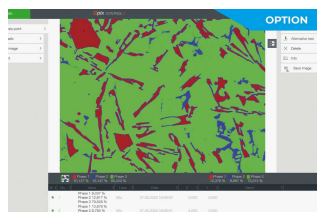
ROCKWELL INDENTATION TEST

Rockwell indentation test for qualitative adhesion evaluation of ceramic coatings in accordance with DIN EN ISO 26443.

STRUCTURAL ANALYSIS MADE EASY

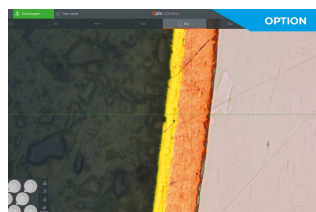
QPIX検査ソフトウェアモジュール

直感的でユーザーフレンドリーなQpix INSPECTソフトウェアの機能は、顕微鏡評価と結果の文書化のための包括的なツールボックスを提供します。この多機能ソフトウェアは、お客様固有の測定タスクに合わせてカスタマイズしたり、アドオンモジュールで補完することができます。



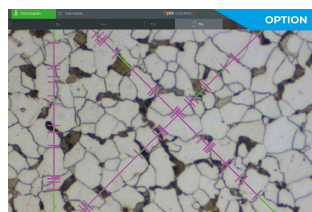
検査段階の分析

- | 画像オブジェクトの自動寸法計測
- | ISO 9042およびASTM E562に基づく位相差の評価
- | 分析結果は、表面の割合（パーセンテージ）または表面の公称値として、表や図で表示されます。



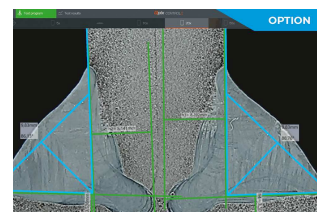
検査層の厚さ測定

- | DIN EN ISO 1463に基づく層の厚さの決定
- | 水平、垂直、半径方向の層を半自動で測定
- | 層の厚さを統計値として表や図にして提供する。



粒子径の測定

- | 粒子径はDIN EN ISO 643およびASTM E112に準拠し、直線法または円形断面法で測定
- | 表や図で示された分析結果
- | 粒子径と粒子を切断するセグメント長の統計的特性の文書化



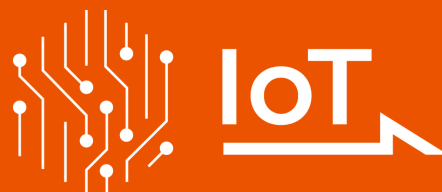
検査 溶接継ぎ目の測定

- | 標準化された測定と溶接継ぎ目の評価
- | スロート厚さ、溶接補強、溶け込み深さなど、すべての関連測定ツールを備えたプレハブ・テンプレート
- | 良品/不良品の自動評価とレポート作成

IOT - INTERNET OF THINGS

デバイスへのリモートアクセスのためのプラットフォーム

QpixControl2とQpixT2ソフトウェアを搭載したすべてのQATM硬さ試験機は、Verder Scientific IoTプラットフォームにシームレスに統合され、機能強化とシームレスな接続性を提供します。



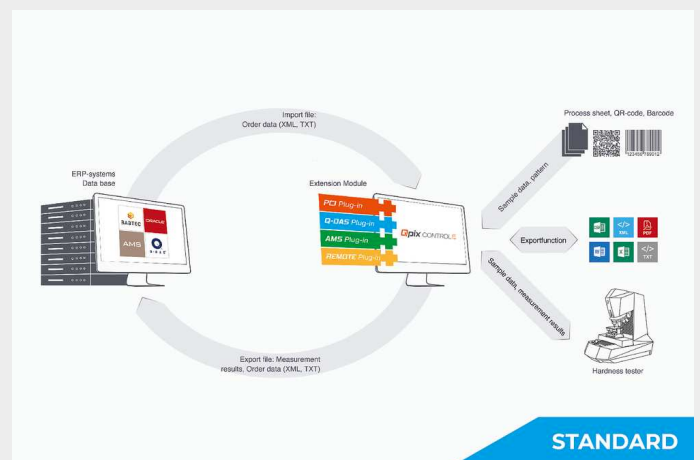
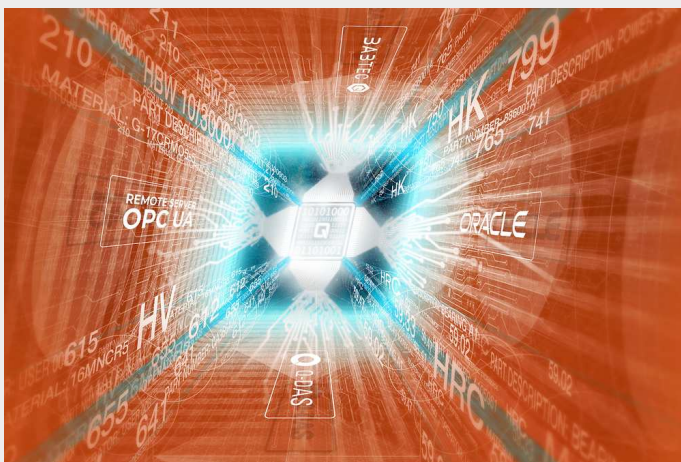
- | リアルタイム・モニタリング：世界中のどこからでもリアルタイムで機械を監視します。このデータ主導のアプローチにより、情報に基づいた意思決定を簡単に行うことができます。
- | ライブ通知：即座のアラートとアップデートで先手を打ちましょう。リアルタイムの通知により、機器のパフォーマンスに関する情報を常に入手できるため、積極的なメンテナンスが可能になります。
- | 簡単バックアップ：データ保護を簡素化します。1台のデバイスをバックアップする必要がある場合でも、全フリートをバックアップする必要がある場合でも、当社のプラットフォームはプロセスを合理化し、ダウンタイムとデータ損失を最小限に抑えます。
- | 自動 & 無料ソフトウェア アップデート：手動更新に別れを告げましょう！ Verder Scientific IoT は、お客様の機械に常に最新のソフトウェアを搭載し、性能と信頼性を最適化します。



インダストリー4.0

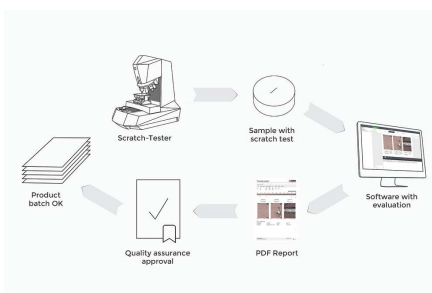
明日のために

Qconnectは、QATM Qpix Control2ソフトウェアのインターフェイスで、シリアル製造、オープンXMLインターフェイス（双方向）、QDAS Plug-Inなどの事前に指定されたプラグインソリューションから、QATMが完全に実装するお客様固有の接続ソリューションまで、デバイス間接続の完全なポートフォリオをお客様に提供します。あらゆるアプリケーション要件に対応する専門的なソリューションをご用意しています。



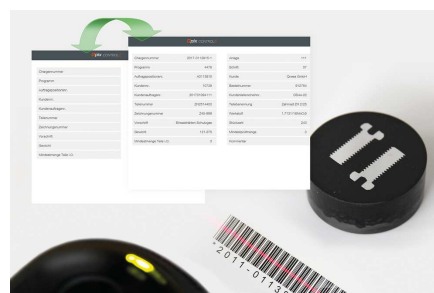
認定品質

DATA EXCHANGE & MONITORING



REPORT & AUTO-EXPORT

Test results, Lc results, scratch
track information, and test



バーコード/ORコード/DMCリーダー

Qpixソフトウェアプラットフォーム
は、バーコードリーダーとQRコード



NFC経由でのログイン

Qpix Control 2ソフトウェアは、外部NFCリーダーを使用したユーザー

parameters can be documented in a structured format and exported. Standardized test reports and flexible export options facilitate the transfer of results to quality assurance, documentation, or higher-level systems.

リーダーに対応しています。ヘッダーファイルの挿入（シリアル）、テンプレートの自動選択のための読み取りデバイスの完全な統合管理、上位システムからのデータの呼び出し（オプション）など、バーコード/QRコードリーダーは、テスターの作業手順を簡素化し、操作ミスを防止します。

ログインをサポートしています。NFCタグ/カードによっては、顧客の既存のアクセスカードもプログラム可能です。



試験荷重範囲	0.5* - 200 N
Constant load	Single measurements
Progressive load	Single measurements
Z-軸	Dynamic, automated (CAS-Technic), Travelling distance Z 150 mm (5.91")
ツール?ポジション	8-fold motorized tool changer (max. 3 testing modules, max. 7 lenses)
Included basic equipment	Rockwell diamond; 20x, 50x Lenses
Lens types	Standard (Achromat) and High Quality (Semi-apochromat) for hardness testing and microscopy
サンプル?イメージ?カメラ	-
Cross slide	Motorized Y axis
テーブル?サイズ	150 x 120 mm (5.91 x 4.72")
Positioning accuracy	Y-axis +/- 0.2 µm
移動経路	Y 150 mm (5.91")
Control elements	Emergency stop, Start button, Joystick Y/Z
ワークピースの最大重量	50 kg (110 lbs)

標準機の重量

58 kg (127.9 lbs)

Optional

Qpix Inspect Module

* 0.5 N and 1 N > 1% accuracy

www.qatm.com/qscratch-20-go

注文データ